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2771-337

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**In re United States Patent Application of:****Applicants: Peter Van Buskirk, et al.****Application No.: 09/200,495****Date Filed: November 25, 1998****Title: OXIDATIVE TOP ELECTRODE DEPOSITION
PROCESS, AND MICROELECTRONIC DEVICE
STRUCTURE**Ex: HU, Showniaig 51A
2811
7-25-00
C. Brown**FACSIMILE TRANSMISSION CERTIFICATE**

I hereby certify that I am filing this document in the United States Patent and Trademark Office on June 2, 2000, by facsimile transmission, addressed to the Commissioner for Patents, Washington, DC 20231, and facsimile transmitted to U.S. PTO Group 2800 facsimile machine at (703) 308-7722. Number of pages transmitted: 5 pages.



Steven A. Hultquist

July 21, 2000

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**AMENDMENT RESPONDING TO APRIL 21, 2000 OFFICE ACTION IN U.S. PATENT
APPLICATION NO. 09/200,495**

Commissioner for Patents
Washington, D.C. 20231

Sir:

In response to the April 21, 2000 Office Action in the above-identified patent application, please amend the application as follows: